



Form PTO-1449

INFORMATION DISCLOSURE CITATION  
IN AN APPLICATION

(Use several sheets if necessary)

Doctor Number (Optional)

T5MC-02-1329

### Arachnida

10/696,642

Appendix Huan-Liang Tseng et al.

Finishing Date: 1/29/12 Group Art Unit

10/29/03

### Group A1 Unit

## U. S. PATENT DOCUMENTS

## FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO

**OTHER DOCUMENTS** (including Author, Title, Date, Portion of Page, Etc.)

(10) - US Patent App. Publication US 2002/0071744 A1 to Bachrach, Pub date 6/13/02, "Compact Apparatus and Method for Storing and Loading Semiconductor Wafer Carriers", US Class 414/217, Filed 1/14/02.

(10) - US Patent App. Publication US 2002/0164242 A1 to Wehrung et al, Pub date 11/7/02, "Control System for Transfer and Buffering", US Class 414/935, Filed 1/24/02.

### EXAMINEE

HAROLD JOYCE

DATE CONSIDERED

7-25-04

**EXAMINER:** Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.